

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Haruki FUKAI et al.

Appln. No.:

Group Art Unit:

Filed: HERewith

For: SEMICONDUCTOR LASER, MANUFACTURING THE SAME AND
SEMICONDUCTOR LASER DEVICE

* * *

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.56, and without any assertion
as to materiality or prior art effect, the documents listed
on the attached Form PTO-1449 are hereby cited.

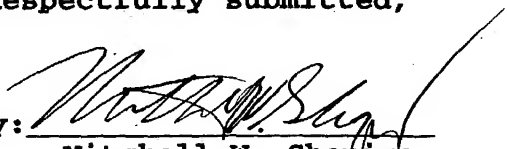
The documents on the attached List were cited in the
specification, on page 2, and their relevance is indicated
therein.

Respectfully submitted,

MWS:lat

Miles & Stockbridge P.C.
1751 Pinnacle Drive
Suite 500
McLean, Virginia 22102-3833
(703) 903-9000

By:


Mitchell W. Shapiro
Reg. No. 31,568

July 11, 2003

FORM PTO-1449		Atty. Docket No. XA-9907	Appln. No.
<u>LIST OF DOCUMENTS CITED BY APPLICANT</u>			
		Applicant Haruki FUKAI et al.	
		Filing Date HEREWITH	Group

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						

FOREIGN PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Country	Class	Sub-class	Translation
	AJ						
	AK						
	AL						
	AM						
	AN						
	AO						

OTHER (including author, title, date, pertinent pages, etc.)

	AP	Ito et al. ed., "Handoutai Laser (Semiconductor Laser)," Baifukan, 1991, Chapter 5 (Kayane).
	AQ	Lin et al., "High-Temperature, Low Threshold Current, and Uniform Operation 1x12 Monolithic AlGaInAs/InP Strain-Compensated Multiple Quantum Well Laser Array in 1.5 μm ," <u>IEEE Transactions on Electron Devices</u> , August 1999, Vol. 46, No. 8, pp. 1614-1618.
	AR	

Examiner	Date Considered
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.